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U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

APPL NUM 10062790	FILING DATE 02/01/2002	CLASS 525	SUBCLASS 1	GAU 152 1711	EXAMINER A. J. JON
**APPLICANTS: Deshpande Shreeram;					
**CONTINUING DATA VERIFIED:					
** FOREIGN APPLICATIONS VERIFIED:					
PG-PUB <input type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/> RESCIND <input type="checkbox"/>					
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no Verified and Acknowledged Examiners's initials				ATTORNEY DOCKET NO 31937	
TITLE : Organic anti-reflective coating compositions for advanced microlithography					

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NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for 0.0
ISSUE FEE			DRAWING	
Amount Due	Date Paid		Sheets Drwg.	Figs. Drwg. Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		Primary Examiner	Applicati n Examiner	
		PREPARED F R ISSUE		
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